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\*\* CONTINUING DATA \*\*\*\*\* NONE LV

\*\* FOREIGN APPLICATIONS \*\*\*\*\* YES LV  
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IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 06/14/2001

|  |   |                              |                         |                       |                            |
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| Foreign Priority claimed<br>35 USC 119 (a-d) conditions met<br>Verified and Acknowledged | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no<br><input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance<br>Examiner's Signature <i>[Signature]</i> Initials <i>LV</i> | STATE OR<br>COUNTRY<br>JAPAN | SHEETS<br>DRAWING<br>11 | TOTAL<br>CLAIMS<br>12 | INDEPENDENT<br>CLAIMS<br>2 |
|--|---|------------------------------|-------------------------|-----------------------|----------------------------|

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TITLE  
 Method for manufacturing semiconductor device, and processing system and semiconductor device

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|------------------------------------|---|--|
| FILING FEE<br><br>RECEIVED<br>1110 | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT<br>No. _____ for following: | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )<br><input type="checkbox"/> 1.18 Fees ( Issue ) |
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